

Update Search

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L17	287	(sharma near3 manish).in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/16 12:07
L18	292	(heon near3 lee).in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/16 12:07
L20	3534	(magnetic adj tunnel\$3 adj junction\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/16 12:10
L22	630	(resistivit\$3) same ((oxidat\$4 oxidiz\$6 nitrid\$6 carburiz\$6) with plasma\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/16 12:11
L23	9	20 and 22	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/16 12:13
L24	1	(17 18) and 22	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/16 12:13

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L12	1488	(magnetic adj tunnel\$3 adj junction\$1)	US-PGPUB	OR	OFF	2006/11/16 11:41
L13	23	12 same ((oxidat\$4 oxidiz\$6 nitrid\$6 carburiz\$6) with plasma\$1)	US-PGPUB	OR	OFF	2006/11/16 11:42
L14	1	13 same (high near5 resistivit\$3) with (electrode\$1)	US-PGPUB	OR	OFF	2006/11/16 11:43

Day : Thursday
Date: 11/16/2006
Time: 12:06:15

PALM INTRANET

Inventor Name Search Result

Your Search was:

Last Name = SHARMA

First Name = MANISH

Application#	Patent#	Status	Date Filed	Title	Inventor Name
08111002	5390017	150	08/24/1993	OPTICAL NETWORK ANALYZER FOR MEASURING THE AMPLITUDE CHARACTERISTIC AND GROUP DELAY TIME DISPERSION CHARACTERISTICS OF AN OPTICAL CIRCUIT DEVICE	SHARMA, MANISH
08211717	5432602	150	04/25/1994	LIGHT WAVELENGTH MEASURING APPARATUS WITH LIGHT MODULATION	SHARMA, MANISH
08389504	5717795	250	02/16/1995	OPTICAL WAVELENGTH DIVISION MULTIPLEXED NETWORK SYSTEM	SHARMA, MANISH
08479012	5839103	150	06/07/1995	SPEAKER VERIFICATION SYSTEM USING DECISION FUSION LOGIC	SHARMA, MANISH
08697446	5739943	150	08/23/1996	POLARIZATION CONTROL UNIT	SHARMA, MANISH
08777203	5918518	150	12/27/1996	APPARATUS AND METHOD FOR CUTTING WEB	SHARMA, MANISH
08813590	6081355	150	03/07/1997	MULTI-WAVELENGTH LIGHT SOURCE	SHARMA, MANISH
08827562	5862519	150	04/01/1997	BLIND CLUSTERING OF DATA WITH APPLICATION TO SPEECH PROCESSING SYSTEMS	SHARMA, MANISH
08976279	Not Issued	161	11/21/1997	USER VALIDATION FOR INFORMATION SYSTEM ACCESS AND TRANSACTION PROCESSING	SHARMA, MANISH
08976280	6539352	150	11/21/1997	SUBWORD-BASED SPEAKER VERIFICATION WITH MULTIPLE-CLASSIFIER SCORE FUSION WEIGHT AND THRESHOLD ADAPTATION	SHARMA, MANISH
09015393	6480825	150	01/29/1998	SYSTEM AND METHOD FOR DETECTING A RECORDED VOICE	SHARMA, MANISH
09210712	6058817	150	12/14/1998	APPARATUS AND METHOD FOR CUTTING WEB	SHARMA, MANISH
09441602	6304622	150	11/17/1999	FLEXIBLE BIT RATE CLOCK RECOVERY UNIT	SHARMA, MANISH
09634370	Not	161	08/09/2000	Positively chirped signals in optical	SHARMA, MANISH


PALM INTRANET

Day : Thursday
Date: 11/16/2006
Time: 12:06:00
Inventor Name Search Result

Your Search was:

Last Name = LEE

First Name = HEON

Application#	Patent#	Status	Date Filed	Title	Inventor Name
08994265	6012550	150	12/19/1997	BYPASS DEVICE FOR AUTOMATIC TRANSMISSION FLUID PROVIDED WITH A THERMAL EXPANSION BAR	LEE, HEON
08998786	6089735	150	12/29/1997	EASY-EXCHANGEABLE HEAD LAMP FOR AUTOMOBILES	LEE, HEON
09172456	6228277	150	10/14/1998	ETCH ENDPOINT DETECTION	LEE, HEON
09374537	6355520	150	08/16/1999	METHOD FOR FABRICATING 4F2 MEMORY CELLS WITH IMPROVED GATE CONDUCTOR STRUCTURE	LEE, HEON
09374538	6294436	150	08/16/1999	METHOD FOR FABRICATION OF ENLARGED STACKED CAPACITORS USING ISOTROPIC ETCHING	LEE, HEON
09383666	6352934	150	08/26/1999	SIDEWALL OXIDE PROCESS FOR IMPROVED SHALLOW JUNCTION FORMATION IN SUPPORT REGION	LEE, HEON
09460318	6362033	150	12/14/1999	SELF-ALIGNED LDD FORMATION WITH ONE-STEP IMPLANTATION FOR TRANSISTOR FORMATION	LEE, HEON
09489771	6214661	150	01/21/2000	Method to prevent oxygen Out-Diffusion from BSTO containing Micro-Electronic device	LEE, HEON
09489865	6261924	150	01/21/2000	Maskless process for self-aligned contacts	LEE, HEON
09583963	6284666	150	05/31/2000	Method of reducing RIE lag for deep trench silicon etching	LEE, HEON
09596484	Not Issued	162	06/19/2000	METHOD TO ETCH POLY SI GATE STACKS WITH RAISED STI STRUCTURE	LEE, HEON
09599703	6326260	150	06/22/2000	Gate prespacers for high density high performance drams	LEE, HEON
09608565	Not Issued	161	06/30/2000	Method of etching noble metals using ion implantation	LEE, HEON
09609472	Not Issued	161	06/30/2000	CONCAVE SHAPED STACK CAPACITOR	LEE, HEON
09660679	Not	161	09/13/2000	Apparatus for etching noble metals using	LEE, HEON